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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: OZAKI, Takashi, et al.

Group Art Unit: 2813

Serial No.: 10/517,765

Examiner: MCCALL SHEPARD, Sony

Filed: February 3, 2006

P.T.O. Confirmation No.: 6791

For.

SUBSTRATE TREATING APPARATUS AND METHOD FOR

MANUFACTURING SEMICONDUCTOR DEVICE

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: April 27, 2009

Sir:

Applicants petition the Commissioner for Patents to extend the tirle for response to the Office Action dated December 1, 2008 for two months, from March 1, 2009 to May 1, 2009.

The Commissioner is authorized to charge our Deposit Account in the amount of \$490.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-234(.

Respectfully submitted,

KRATZ, QUINTOS & HANSON, LLP

Agent for Applicant Reg. No. 40,899

JNB/ak

Atty. Docket No. 040509 Suite 400 1420 K Street, N.W. Washington, D.C. 20005 (202) 659-2930

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PATENT & TRADEMARK OFFICE

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